

Tango Systems Inc. Has Moved

SAN JOSE, Calif., February. 04, 2016 – Tango Systems Inc., a leading innovator in high-performance, cost-effective physical vapor deposition (PVD) systems announced today it has moved its corporate offices as well as the applications lab and manufacturing operations to 1980 Concourse Drive, San Jose. The new office will be approximately two miles from its previous location.

The space will accommodate Tango's current and future growth as well as provide a new class 10 clean room and class 10000 manufacturing area. In addition to increasing manufacturing and office space Tango will add training facilities for customers for process and equipment.

The applications and demo lab will be equipped with the latest equipment for Fan Out wafer and panel level processing as well as for EMI shielding applications. This is in addition to existing Advanced Packaging capabilities like RDL and high aspect ratio TSV (Through Silicon Vias).

About Tango Systems Inc.

Based in the heart of Silicon Valley, Tango Systems, Inc., a leading innovator in high-performance, cost-effective PVD systems has been supplying PVD metal sputtering equipment for over 10 years. The focus on application areas include Fan Out processing and EMI shielding as well as Advanced Packaging, Hard Disk Drive, Ultra-thin films, Interposers and TSV. Customers benefit from Tango Systems' processing through ease of maintenance, high throughput, lowest Cost-of-Ownership (CoO), high tool availability and low temperature PVD processing.